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Applicant(s)

Mineo HIRAMATSU and Masaru HORI

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Not Yet Assigned

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	11-67490	03/09/1999	Japan			ABS	
	2003-173980	06/26/2003	Japan			ABS	
	2001-81570	03/27/2001	Japan			ABS	

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

Mineo HIRAMATSU, et al., "Fabrication of Carbon Nanowalls Using RF Plasma CVD" Abstracts for The 16th Symposium on Plasma Science for Materials, pp. 20, A2-4.

Mineo HIRAMATSU, et al., "Fabrication of vertically aligned carbon nanowalls using capacitively coupled plasma-enhanced chemical vapor deposition assisted by hydrogen radical injection", Applied Physics Letters, Vol. 84, No. 23, pp. 4708-4710 (2004).

EXAMINER	/Mandy Louie/	DATE CONSIDERED	11/21/2009
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.